

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hong Sick Park et al. Examiner: Savitri Mulpuri
Serial No: 10/516,602 Group Art Unit: 2812
Filed: July 5, 2005 Docket: 8071-152T (OPP 031969US)
For: **A METHOD OF FORMING A METAL PATTERN AND A
METHOD OF FABRICATING TFT ARRAY PANEL BY USING
THE SAME**

Mail Stop: RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Final Office Action dated September 13, 2006, please amend the above-referenced patent application as set forth herein. Also, accompanying this amendment is a Request for Continued Examination (RCE).
